<table>
<thead>
<tr>
<th><strong>Title</strong></th>
<th>Band excitation Kelvin probe force microscopy utilizing photothermal excitation</th>
</tr>
</thead>
<tbody>
<tr>
<td><strong>Authors(s)</strong></td>
<td>Collins, Liam; Jesse, S.; Balke, Nina; Rodriguez, Brian J.; et al.</td>
</tr>
<tr>
<td><strong>Publication date</strong></td>
<td>2015</td>
</tr>
<tr>
<td><strong>Publication information</strong></td>
<td>Applied Physics Letters, 106 :</td>
</tr>
<tr>
<td><strong>Publisher</strong></td>
<td>American Institute of Physics</td>
</tr>
<tr>
<td><strong>Item record/more information</strong></td>
<td><a href="http://hdl.handle.net/10197/6479">http://hdl.handle.net/10197/6479</a></td>
</tr>
<tr>
<td><strong>Publisher’s version (DOI)</strong></td>
<td>10.1063/1.4913910</td>
</tr>
</tbody>
</table>
Band excitation Kelvin probe force microscopy utilizing photothermal excitation

Liam Collins,1,2,a) Stephen Jesse,3 Nina Balke,3 Brian J. Rodriguez,1,2 Sergei Kalinin,3 and Qian Li3,a)

1School of Physics, University College Dublin, Belfield, Dublin 4, Ireland
2Conway Institute of Biomolecular and Biomedical Research, University College Dublin, Belfield, Dublin 4, Ireland
3Center for Nanophase Materials Sciences, Oak Ridge National Laboratory, Oak Ridge, Tennessee 37831, USA

(Received 8 February 2015; accepted 19 February 2015; published online 13 March 2015)

A multifrequency open loop Kelvin probe force microscopy (KPFM) approach utilizing photothermal as opposed to electrical excitation is developed. Photothermal band excitation (PthBE)-KPFM is implemented here in a grid mode on a model test sample comprising a metal-insulator junction with local charge-patterned regions. Unlike the previously described open loop BE-KPFM, which relies on capacitive actuation of the cantilever, photothermal actuation is shown to be highly sensitive to the electrostatic force gradient even at biases close to the contact potential difference (CPD). PthBE-KPFM is further shown to provide a more localized measurement of true CPD in comparison to the gold standard ambient KPFM approach, amplitude modulated KPFM. Finally, PthBE-KPFM data contain information relating to local dielectric properties and electronic dissipation between tip and sample unattainable using conventional single frequency KPFM approaches. © 2015 AIP Publishing LLC. [http://dx.doi.org/10.1063/1.4913910]

Since its inception in 1991,1 Kelvin probe force microscopy (KPFM) has had extraordinary success studying local electrochemical,2,3 electronic,4,5 and transport properties6–8 of materials and devices with nanometer resolution. KPFM has been particularly useful for characterizing materials and devices ranging from metals,1 semiconductors,8,9 and ferroelectrics,10,11 to self-assembled monolayers,12 polymers,13 and biomolecules.14,15 The continued success of KPFM necessitates both the advancement of the technique in terms of accuracy and resolution9,16,17 across all imaging environments,18,19 as well as improved capabilities to distinguish and correlate different electronic parameters (i.e., dielectric properties,20–23 dissipation24,25) beyond that currently attainable with conventional KPFM.

Although several KPFM “modes” or techniques have been developed,36 most are based on a closed loop bias feedback approach, where an AC voltage (V_{ac}) is applied to a conductive probe such that V_{probe} = (V_{dc} + V_{cpd}) + V_{ac} \cos(\omega t), where V_{cpd} is the built-in contact potential difference (CPD) between tip and sample, and V_{dc} is the DC bias controlled by a feedback loop. The driving frequency \omega is typically chosen to be close to the cantilever resonance frequency (\omega_{0}) to achieve an amplified cantilever response and hence increased signal to noise ratio. The periodic voltage results in static and dynamic electrostatic forces acting on the tip

\[ F_{dc} = -C'_{z} \left( \frac{1}{2} (V_{dc} - V_{cpd})^2 + \frac{1}{4} V_{ac}^2 \right), \]  
\[ F_{\omega} = -C'_{z} (V_{dc} - V_{cpd}) V_{ac} \sin(\omega t), \]  

where \( C'_{z} \) is the capacitance gradient. In amplitude modulation (AM)-KPFM, a lock-in amplifier (LIA) is employed to extract the amplitude (A(\omega)) and phase (\phi(\omega)) response due to the first harmonic force, Eq. 1(b), at the frequency of electrical excitation. The mixed amplitude response (A(\omega) \cos(\phi(\omega))) is used as an input to the feedback loop, which works to continually minimize the response (i.e., F(\omega) = 0) by adjusting V_{dc} to equal V_{cpd} between the probe and the sample. Assuming ideal KPFM operation, a map of V_{cpd} at each point on the surface can be obtained, however, KPFM closed loop bias feedback is regarded as being non-ideal11,27–29 At best the amplitude response due to F(\omega) can be minimized to the noise level of the system. Furthermore, CPD values measured by KPFM have been shown to be strongly dependent on experimental parameters including V_{ac},30 the operational distance,31 and, more worryingly, topographical crosstalk.29,32 These parameters can result in systematic errors of hundreds of millivolts in the recorded V_{cpd} in an instrument specific way, making comparison between experiments or with theory difficult.27,28 Several attempts to negate these artifacts present in conventional KPFM have been pursued through the development of KPFM techniques based on heterodyne detection,17 dual harmonic detection in open,27,33 and closed loop,34 as well as band excitation (BE)-KPFM.29,35

Another significant problem in AM-KPFM measurements is stray capacitive coupling between different parts of the probe architecture and sample surface under test, which limits the achievable resolution of KPFM measurements. Not only is the conductive tip apex electrostatically interacting with the sample, but the probe cone and cantilever are...
also influencing the imaging mechanism over a larger sample area. Therefore, an AM-KPFM image can be regarded as a weighted average of the CPD across the sample surface and is not solely indicative of the area directly underneath the tip apex. This complication is circumvented to a large degree by frequency modulation (FM)–KPFM, which is sensitive to the electrostatic force gradient \( F'_{dc} \) as opposed to the force. The electrostatic force gradient is more sensitive to changes taking place directly under the tip as it decays on much shorter length scales than the electrostatic force and hence is not heavily influenced by the probe cone or cantilever. Note that for the static DC force gradient, \( F'_{dc} \), the cantilever resonance frequency shifts as described by

\[
\Delta \omega \approx \omega_0 / 2k(F'_{dc}),
\]

(2a)

where \( k \) is the cantilever spring constant and

\[
F'_{dc} = - C''_z \left( \frac{1}{2} (V_{dc} - V_{cpv})^2 + \frac{1}{4} V_{ac}^2 \right),
\]

(2b)

where \( C''_z \) is the derivative of the capacitance gradient. Although FM-KPFM leads to higher lateral resolution, it is also known to suffer from decreased bias sensitivity compared to AM-KPFM and requires large \( V_{ac} \), which can be problematic when characterizing voltage-sensitive materials. Noteworthy, closed loop KPFM techniques only provide a single parameter map of the \( V'_{cpv} \), whereas further information on local dielectric properties or electronic dissipation is attainable using open loop (OL) electrostatic force microscopy (EFM). Recently, BE-KPFM has shown promise in capturing information beyond what is obtainable using conventional KPFM and or EFM alone.

In this work, we utilize the BE approach to compare the implementation of different physical actuation mechanisms for multifrequency KPFM, namely, capacitive (i.e., OLBE-KPFM) and photothermal (i.e., photothermal (Pth)BE-KPFM) actuation. Both approaches operate in open loop, negating complications arising from closed loop bias feedback as well as being sensitive to the electrostatic force gradient overcoming to a large degree the stray capacitance effect. The sensitivity to small changes in the electrostatic force gradient is compared between the newly developed PthBE-KPFM and the previously reported OLBE-KPFM.

Finally, we compare PthBE-KPFM with the gold standard for surface potential mapping in ambient, namely, AM-KPFM.

BE, unlike single frequency detection, allows the full cantilever response to be determined in a frequency band typically comprising the cantilever resonance peak. Combined with open loop KPFM bias spectroscopy, BE can be used to map electronic properties of the sample under test. Fig. 1(a) shows a schematic of the setup used in this work. All BE-KPFM techniques shown here are performed on an Asylum Research Cypher platform equipped with a photothermal excitation module (BlueDrive™) and a home-built BE controller. Measurements were performed with as-received Pt/Ir-coated (Nanosensors, PPP-EFM) AFM probes with a nominal mechanical resonance frequency and spring constant of 75 kHz and 2.8 N/m, respectively. We use a NI PXI-6124 card with two analog outputs to synchronously generate BE and DC waveforms that are digitally constructed from a set of parameters, e.g., bandwidth, amplitude, and pulse length.

Common to both capacitive and photothermal actuation open loop KPFM approaches is the use of DC bias pulses applied directly to the cantilever, used to induce changes in the electrostatic interactions between probe and sample. BE waveforms are used to detect the resultant changes in the dynamic cantilever response by recording the resonance peak of the oscillating cantilever. The difference between OLBE-KPFM and PthBE-KPFM is simply where the BE signal is supplied for excitation. In OLBE-KPFM, the BE excitation waveform is applied as a voltage directly to the conductive probe, as shown in Fig. 1. Conversely, in PthBE-KPFM, the BE waveform is used to modulate the photothermal laser module directly, as shown in Fig. 1. In photothermal excitation, the laser modulates the temperature of the cantilever base, resulting in cantilever oscillation based on thermal expansion. PthBE has previously been used to measure bias induced transitions based on short range interactions with the sample. In this work, we describe how a similar methodology applied to KPFM, operated in non-contact, can be used to extract quantitative information on local electrochemical and electronic properties. In the current setup, we perform BE-KPFM in a grid measurement where the tip is moved along a dense grid of points, and at each grid position, the tip is brought into contact to find the sample surface and then immediately

![FIG. 1. Schematic of the working principle behind both OLBE (red dashed line) and PthBE (blue line)—KPFM utilizing electrostatic and photothermal excitation of the cantilever, respectively. Modulation of the excitation signal is performed in a band of frequencies comprising the cantilever resonance. Voltage spectroscopy is performed in this case using a DC bipolar square wave applied between a conductive probe and sample.](image-url)
retracted a defined sample distance (typically 50–200 nm) before voltage modulation begins. On receiving each BE waveform, the cantilever starts to oscillate at the chosen band of frequencies. The time domain responses of the cantilever are acquired over the same time length and then Fourier transformed into frequency domain response spectra, which contain the tip-sample interaction information. The simple harmonic oscillator (SHO) model can accurately describe a free resonance frequency spectrum, which has amplitude/phase forms as

\[
A(\omega) = \frac{0_0^2 A_{\text{drive}}}{\sqrt{(\omega_0^2 - \omega^2)^2 + (\omega_0/Q)^2}} \tag{3a},
\]

\[
\varphi(\omega) = \tan^{-1}\left(\frac{\omega_0\omega}{Q(\omega_0^2 - \omega^2)}\right) + \varphi_{\text{drive}}, \tag{3b}
\]

where \(\omega_0\) is the resonance frequency and quality \((Q)\) factor; \(A_{\text{drive}}\) and \(\varphi_{\text{drive}}\) are the amplitude and phase, respectively, of the driving force.

Fig. 2 shows comparative measurements between OLBE- and PthBE-KPFM performed sequentially at a distance of 60 nm above an Au electrode. Fig. 2(a) depicts a single point OLBE amplitude spectrum, showing strong variation in the cantilever transfer function as a function of \(V_{dc}\). In the case of OLBE, where the system is capacitively driven, we expect a linear \(V_{dc}\) dependence of the amplitude, Fig. 2(c), which becomes nullified at \(V_{cpd}\) governed by the first harmonic electrostatic force, Eq. 1(b). Note, linear fitting of this response can be used to determine CPD and capacitance gradient from the nulling bias of the amplitude response and slope, respectively. Additionally, BE allows passive tracking of the resonance frequency, which demonstrates a parabolic bias dependence, as described by the electrostatic force gradient, Eq. 2(b). In this case, the parabola maximum corresponds to the CPD. This KPFM measurement is expected to have a higher spatial resolution as described previously for FM-KPFM. Note that, from Fig. 2(d), the electrical excitation approach (i.e., OLBE-KPFM) suffers from poor sensitivity at biases approaching the CPD value. The response becomes increasingly smaller approaching the CPD, eventually becomes nullified at precisely \(V_{cpd}\), decreasing the accuracy of the SHO fitting procedure used to determine the resonance frequency. The results of a similar measurement collected using PthBE-KPFM are shown. In PthBE-KPFM, Fig. 2(c), a strong cantilever response is recorded, which is largely independent of applied bias. This is expected from photothermal excitation as it is more insensitive to long range electrostatic force than OLBE-KPFM. PthBE-KPFM is, however, highly sensitive to the electrostatic force gradient as evident from the change in resonance frequency shown in Fig. 2(d), and is shown to be more sensitive to small changes in the resonance frequency at bias values close to the CPD in comparison to OLBE-KPFM.

To illustrate PthBE-KPFM imaging, we have chosen a model sample combining topographic, material, and charge contrast, as shown in Fig. 3. Fig. 3(a) shows the AFM topography of the test sample formed by an Au electrode deposited on a Si surface with a native oxide, having a step of about 150 nm of height. A positive charge region is written on a SiO\(_x\) surface using bias lithography by scanning a tip biased with 9 V in contact mode using a scan rate of 0.5 Hz in an area of 1.5 \(\mu\text{m}^2\) indicated in Fig. 3(a). Measurements were first performed using classical KPFM operated in lift mode (lift height = 50 nm) using AM detection. In AM-KPFM, Fig. 3(b), a CPD of 502 ± 18 mV and 202 ± 9 mV was found for SiO\(_x\) and Au, respectively. The CPD of the charged SiO\(_x\) region increased by approximately 351 mV to 853 ± 19 mV in comparison to uncharged SiO\(_x\). In general, it is clear that the charged region observed using AM-KPFM (Fig. 3(b)) is much more diffuse that the physically charged region indicated in Fig. 3(a), likely a consequence of the
long range nature of the electrostatic force interaction. Next, the same area was measured using PthBE-KPFM across a 100 × 50 grid using a BE excitation of 250 mV centered at 72 kHz having a bandwidth of 20 kHz and 129 bins per band. The DC bias waveform was within the range of ±8 V having 64 steps per waveform. The CPD was calculated for each position by parabolic fitting of the bias dependence of the resonance frequency. In PthBE-KPFM, Fig. 3(c), a CPD of 945 ± 16 mV and 560 ± 5 mV was found for SiOₓ and Au, respectively. PthBE-KPFM shows a higher CPD (2.18 ± 0.03 V) and represents a more localized measurement of the true CPD of the charge region than observed using standard AM-KPFM, likely due to detection of the electrostatic force gradient, which is localized to the last few nanometers of the tip apex. Note that information on the dielectric properties is also determined from the fitting procedure, providing the C’代表 as shown in Fig. 3(d). Clear contrast in material properties between SiOₓ and Au can be observed in the C’代表 map, having a sharp transition region at the boundary. Furthermore, no indications of variation in dielectric constant in the charged region are observed, suggesting the dielectric constant remains constant in this region, in agreement with the absence of an oxide layer growth in the topography image. From the line scan analysis (Figs. 3(e)–3(h)), it is clear that the PthBE method, even operated in grid mode having less sampling pixels, shows

FIG. 4. (a) and (d) Resonance frequency, (b) and (e) amplitude, (c) and (f) and Q factor recorded using PthBE-KPFM at (a)–(c) positive 8 V and (d)–(f) negative 8 V, respectively. Bias dependence of the (g) resonance frequency, (h) amplitude, and (i) Q factor from (green) uncharged SiOₓ (red) charged SiOₓ and (blue) Au.
This article is copyrighted as indicated in the article. Reuse of AIP content is subject to the terms at: http://scitation.aip.org/termsconditions. Downloaded to IP: 

This research was conducted at the Center for Nanophase Materials Sciences, which is sponsored at Oak Ridge National Laboratory by the Scientific User Facilities Division, Office of Basic Energy Sciences, U.S. DOE. Personal support was provided by the U.S. DOE, Basic Energy Sciences, Materials Sciences and Engineering Division through the Office of Science Early Career Research Program (N.B. and Q.L.).


